Imoje

In re Application of:

**MASATAKA ITO** 

Application No.: 10/091,461

Filed: March 7, 2002

For: SOI SUBTRATE, ANNEALING METHOD THEREFOR, SEMICONDUCTOR DEVICE

HAVING THE SOI SUBTRATE, AND

METHOD OF MANUFACTURING THE SAME

Docket No.

00862.022541.

Examiner: S. Isaac

Group Art Unit: 2812

Date: February 20, 2004

Mail Stop Non Fee Amendment THE COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below

| CLAIMS AS AMENDED                       |  |       |  |                         |                |                   |  |
|---|--|-------|--|-------------------------|----------------|-------------------|--|
|   | (2)<br>CLAIMS<br>REMAINING<br>AFTER<br>AMENDMENT |       | (4)<br>HIGHEST NO.<br>PREVIOUSLY<br>PAID FOR | (5)<br>PRESENT<br>EXTRA | RATE           | ADDITIONAL<br>FEE |  |
| TOTAL<br>CLAIMS                         | *<br>16  | MINUS | **   | = 0                     | x \$9<br>\$18  | \$0.00            |  |
| INDEP.<br>CLAIMS                        | * 2  | MINUS | ***  | 0                       | x \$43<br>\$86 | \$0.00            |  |
| Fee for Mu                              | \$0.00   |       |  |                         |                |                   |  |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT |  |       |  |                         |                | \$0.00            |  |

\* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

\*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

\*\*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

(Date of Deposit)

George K. Ng, Reg. No. \$4,334

(Name of Attorney for Applicant)

Date of Signature

|   | Verified Statement claiming small entity status is enclosed, if not filed previously.   |
|---|---|
|   | A check in the amount of \$ is enclosed.  |
|   | Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed  |
| X | Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06 1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed. |
|   | A check in the amount of \$ to cover the fee for a month extension is enclosed.   |
|   | A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.  |
| X | Applicant's undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.  |
|   | Respectfully submitted,   |
|   | Attorney for Applicant  Registration No. 54, 334  |
|   | Registration No. 31, 334  |

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

Form #120

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| RIV.                        |                       |   | •                       |
|-----------------------------|-----------------------|---|-------------------------|
| In re Application of:       |                       | ) |                         |
|                             |                       | : | Examiner: S. Isaac      |
| MASATAKA ITO                |                       | ) |                         |
|                             |                       | : | Group Art Unit: 2812    |
| Application No.: 10/091,461 |                       | ) |                         |
|                             |                       | : |                         |
| Filed: March 7, 2002        |                       | ) |                         |
|                             |                       | : |                         |
| For:                        | SOI SUBSTRATE,        | ) |                         |
|                             | ANNEALING METHOD      | : |                         |
|                             | THEREFOR,             | ) |                         |
|                             | SEMICONDUCTOR DEVICE  | : |                         |
|                             | HAVING THE SOI        | ) |                         |
|                             | SUBSTRATE, AND METHOD | : |                         |
|                             | OF MANUFACTURING THE  | ) | ·                       |
|                             | SAME                  | : | Date: February 20, 2004 |
| Mail S                      | top Non Fee Amendment |   |                         |
|                             | issioner for Patents  |   |                         |
|                             | ox 1450               |   |                         |
| Alexar                      | ndria, VA 22313-1450  |   |                         |
|                             | · ·                   |   |                         |

## **AMENDMENT**

Sir:

In response to the Office Action dated November 20, 2003, please amend the above-identified application as follows.

| I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on |
|---|
| February 20, 2004   |
| (Date of Deposit)   |
| George K. Ng, Reg. No. 54,344   |
| (Name of Attorney for Applicant)  |
| Signature February 20, 2004  Date of Signature  |